

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Luetzen, *et al.* Docket No.: INF 2004 SP 00115 US
Serial No.: 10/721,225 Art Unit: 1763
Filed: November 26, 2003 Examiner: Goudreau, George A.
For: Method and Structures for Increasing the Structure Density and the Storage
Capacitance in a Semiconductor Wafer

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's
Office Action mailed May 17, 2007. Please amend the above-referenced application as follows.